

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|------|---|-----------------|------------------|---------|------------------|
| L1 | 40 | (tele-centric\$4 or tele adj2 centric\$3 or telecentric\$4)same(ghost\$4) | US-PGPUB; USPAT | OR | ON | 2005/05/27 07:53 |
| L2 | 3906 | (tele-centric\$4 or tele adj2 centric\$3 or telecentric\$4)same(imag\$3) | US-PGPUB; USPAT | OR | ON | 2005/05/27 07:49 |
| L3 | 31 | 2 same(ghost\$4) | US-PGPUB; USPAT | OR | ON | 2005/05/27 07:55 |
| L4 | 135 | 2 same(planar\$4 or curfac\$4) | US-PGPUB; USPAT | OR | ON | 2005/05/27 07:45 |
| L5 | 1887 | 2 same(planar\$4 or surfac\$4) | US-PGPUB; USPAT | OR | ON | 2005/05/27 07:45 |
| L6 | 21 | 5 same(ghost\$4) | US-PGPUB; USPAT | OR | ON | 2005/05/27 07:45 |
| L7 | 5152 | (tele-centric\$4 or tele adj2 centric\$3 or telecentric\$4) | US-PGPUB; USPAT | OR | ON | 2005/05/27 07:49 |
| L8 | 25 | 7 same(ghost\$4 near10 imag\$3) | US-PGPUB; USPAT | OR | ON | 2005/05/27 10:50 |
| L9 | 1 | "5748305".PN. | USPAT; USOCR | OR | ON | 2005/05/27 07:52 |
| L10 | 1 | "5583632".PN. | USPAT; USOCR | OR | ON | 2005/05/27 07:52 |
| L11 | 1 | "5251010".PN. | USPAT; USOCR | OR | ON | 2005/05/27 07:52 |
| L12 | 1 | "6563650".PN. | USPAT; USOCR | OR | ON | 2005/05/27 07:53 |
| L13 | 1 | "6324014".PN. | USPAT; USOCR | OR | ON | 2005/05/27 07:53 |
| L14 | 1 | "6220713".PN. | USPAT; USOCR | OR | ON | 2005/05/27 07:53 |
| L15 | 1 | "6220713".PN. | USPAT; USOCR | OR | ON | 2005/05/27 07:53 |
| L16 | 1 | "6220713".PN. | USPAT; USOCR | OR | ON | 2005/05/27 07:53 |
| L17 | 1 | "6195209".PN. | USPAT; USOCR | OR | ON | 2005/05/27 07:54 |
| L18 | 1 | "6185047".PN. | USPAT; USOCR | OR | ON | 2005/05/27 07:57 |
| L19 | 1 | "6023365".PN. | USPAT; USOCR | OR | ON | 2005/05/27 07:57 |
| L20 | 1 | "5999306".PN. | USPAT; USOCR | OR | ON | 2005/05/27 07:57 |
| L21 | 1 | "5999306".PN. | USPAT; USOCR | OR | ON | 2005/05/27 07:58 |

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|-----|---|---------------|-----------------|----|----|------------------|
| L22 | 1 | "5548443".PN. | USPAT; USOCR | OR | ON | 2005/05/27 07:58 |
| L23 | 1 | "6222676".PN. | USPAT; USOCR | OR | ON | 2005/05/27 10:50 |
| L24 | 1 | "6147808".PN. | USPAT; USOCR | OR | ON | 2005/05/27 10:50 |
| L25 | 1 | "6124977".PN. | USPAT; USOCR | OR | ON | 2005/05/27 10:50 |


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Key: IEEE JNL = IEEE Journal or Magazine, IEEE JNL = IEEE Journal or Magazine, IEEE CNF = IEEE Conference, IEEE CNF = IEEE Conference, IEEE STD = IEEE Standard

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